

Substitute for form 1449A/PTO RADE NOTE INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet 1 of 1

Complete if Known		
Application Number	10/695,620	
Filing Date	October 27, 2003	
First Named Inventor	Alexander Kadyshevitch	
Art Unit	2881	
Examiner Name	Vanore, David A.	
Attorney Docket Number		

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-Issue number(s), publisher, city and/or country where published.	т
\mathcal{N}		YACOBI ET AL., Scanning Electron Microscopy (Chapter 2), Micro Analysis of Solids, Plenum Press, New York, 1994.	
N		YAMADA ET AL., An In-Line Process Monitoring Method Using Electron Beam Induced Substrate Current, Microelectronics-Reliability, March 2001, pages 455-459.	
xaminer		Date T / /	

*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

Considered

'Applicant's unique citation designation number. 'Applicant is to place a check mark here if English language Translation is attached.

Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wtr) 08/11/2003. Send To: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Signature